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02/13/02

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10073314	02/13/2002	257	71	2814	<i>FAK-HANI</i>

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\*\*CONTINUING DATA VERIFIED:

\*\* FOREIGN APPLICATIONS VERIFIED:

JAPAN 2001-162788 05/30/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

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TITLE : Semiconductor device and alignment sensing method for semiconductor device

U.S. DEPT. OF COMM./PAT & TM-PTO-436 (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claims for
		0.0	0.0
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheet 1 Draw	Fig. Draw
			Print Fig
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>Application Examiner</b>	
		<b>PREPARED FOR ISSUE</b>	
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